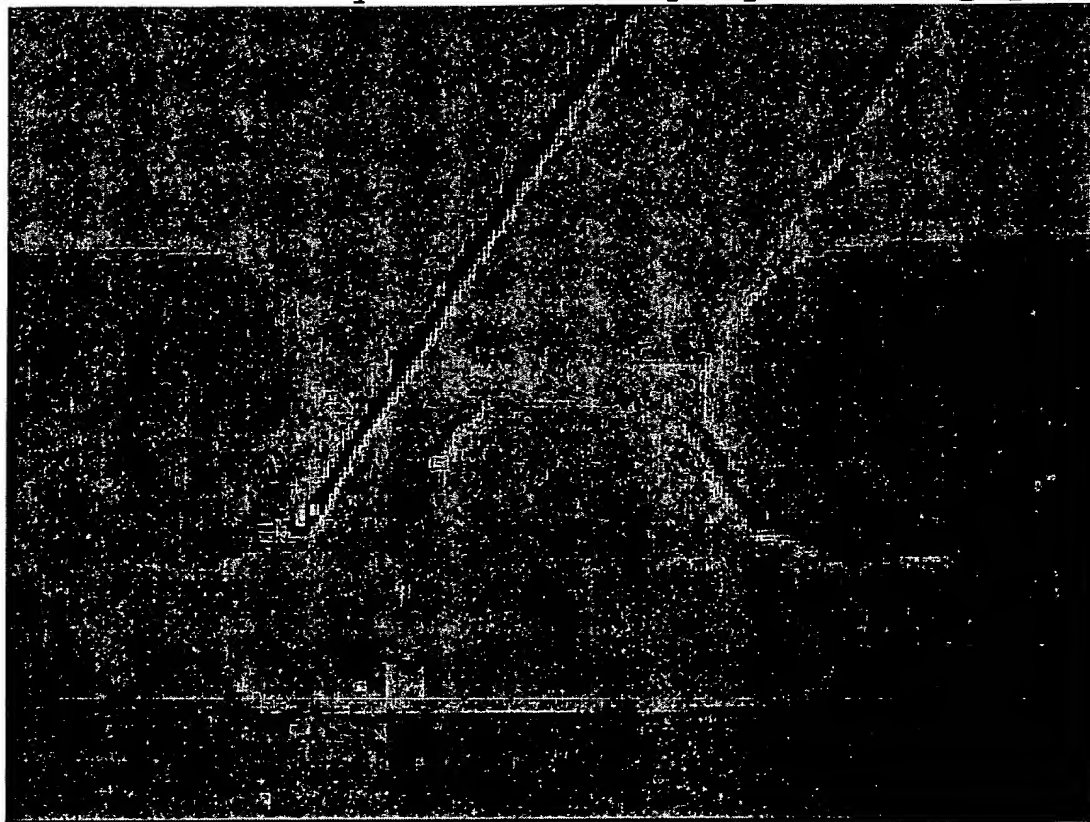


Dielectric layer formed by sputtering process



Dielectric layers formed by MOD process

